David Neims Supervisory Patent Examiner Technology Cember 2808

DETAILED ACTION

1. Applicant's Amendment filed 02/10/2005 has been reviewed and placed of record in the file.

Terminal Disclaimer

2. The terminal disclaimer filed on 02/10/2005 disclaiming the terminal portion of any patent granted on this application which would extend beyond the expiration date of U.S. Patent 6,762,483 has been reviewed and is accepted. The terminal disclaimer has been recorded.

Allowable Subject Matter

3. Claims 1, 2, 7-12, 14, and 16 are allowable over the prior art of record.

The following is an examiner's statement of reasons for allowance: The prior art of record fails to teach or render obvious a MOSFET device and a method for forming a MOSFET device having all exclusive limitations as recited in claims 1 and 10, comprising a source, a drain, and a fin structure formed on an insulating layer, the fin structure including a first region formed in a channel area of the fin structure, characterized in that a dielectric layer is formed around at least the channel area to a thickness ranging from 0.6 nm to less than 1.0 nm and a protective layer is formed over at least the first region of the fin structure, the protective layer being wider than the first region and including an oxide layer and a nitride layer; or characterized in forming a TEOS layer over the MOSFET device before trimming the fin structure, forming a first polysilicon

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layer on the TEOS layer, and forming a second polysilicon layer to act as a gate for the

MOSFET.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for

Allowance."

Conclusion

4. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Tu-Tu Ho whose telephone number is (571) 272-1778. The examiner can normally be reached on 6:30 am - 5:00 pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, DAVID NELMS can be reached on (571) 272-1787. The fax phone number for the

organization where this application or proceeding is assigned is (703) 872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

"H

Tu-Tu Ho March 21, 2005

David Neims
Supervisory Patent Examinar
Technology Center 2800